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**CAPACITOR ON THE SEMICONDUCTOR WAFER**

Appl. No. : 10/709,846 Confirmation No. 3845  
Applicant : Ching-Huei Tsai  
Filed : June 1, 2004  
TC/A.U. : 2811  
Examiner : Owens, Douglas W  
Docket No. : NAUP0572USA  
Customer No. : 27765

Commissioner for Patents  
P.O. Box 1450  
Alexandria VA 22313-1450

Subject: Request for Continued Examination (RCE) in response to the  
Office action dated 04/06/2006

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**INTRODUCTORY COMMENTS**

Dear Sir:

10 In response to the Office action of April 6, 2006, the above-identified  
application is to be amended as indicated in the following section.

**Amendment to the claims** are reflected in the listing of claims which  
begins on page 2 of this paper.

15 **Remarks/Arguments** begin on page 5 of this paper.